



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Jammy et al.

Examiner: M. Estrada

Serial No: 09/363,523 ✓

Group Art Unit: 2823

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Docket: 99 P 7722 US 01 (8706-297)

Date: January 12, 2001

For: METHOD FOR FORMING CRYSTALLINE SILICON NITRIDE

Assistant Commissioner for Patents
Washington, D.C. 20231

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TECHNOLOGY CENTER 2800

RESPONSE UNDER 37 C.F.R. §1.111

Sir:

This is a Response to the Office Action mailed on October 12, 2000. Please consider the following amendments and remarks.

CERTIFICATE OF MAILING 37 C.F.R. §1.8(a)

I hereby certify that this correspondence (and any document referred to as being attached or enclosed) is being deposited with the United States Postal Service as first class mail, postage paid in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on January 12, 2001.

Dated: 1/12/01

Alexander J. Burke, Reg. No.: 40,425